

<b>Notice of References Cited</b>	Application/Control No. 10/641,143	Applicant(s)/Patent Under Reexamination PARK ET AL.	
	Examiner Chen-Wen Jiang	Art Unit 3744	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2004/0035133 A1	02-2004	Park et al.	62/324.1
*	B	US-2004/0035135 A1	02-2004	Park et al.	62/324.6
	C	US-			
	D	US-			
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	F	US-			
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

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